

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of : Group Art Unit: 2818
Akihiko ISHIBASHI, et al. :
Serial No.: 10/017,389 : Examiner: MAI HUONG C. TRAN
Filed: December 18, 2001 :
For: METHOD FOR FABRICATING SEMICONDUCTOR, METHOD
FOR FABRICATING SEMICONDUCTOR SUBSTRATE, AND
SEMICONDUCTOR LIGHT EMITTING DEVICE

TECHNICAL DRAWINGS 2000

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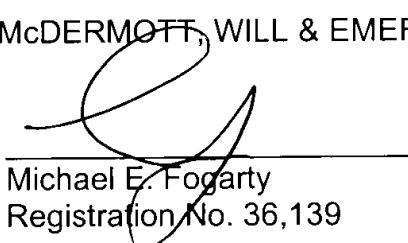
Sir:

The undersigned attorney, being of record in the subject application, hereby authorizes SOKBAN CHAU and VIRGINIA CLICK to inspect and to make copies from the subject application.

Respectfully submitted,

McDERMOTT, WILL & EMERY

Dated: 7/28/03 By:


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SUBSTRATE, AND SEMICONDUCTOR)
LIGHT EMITTING DEVICE)

POWER TO INSPECT AND MAKE COPIES

Honorable Commissioner for Patents and Trademarks
Washington, D.C. 20231

Sir:

The undersigned attorney of record hereby authorizes Billie J. Huffman to inspect and/or make copies of the subject application including any and all documents associated therewith.

Respectfully submitted,


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